Vintage Date	1994	Disaasembly		Chamber Type	ICP
Tool Code		Assembly			
		Final Test		Copuing an Exising System	
		Source Inspection		Copy of Syscon File Availade	

System Diagram

Wafer Size	Wafer Shape	SMIF Interface	MF Facilities	System Power
200mm	Free	No	Std	208[V]

Back Chamber	ICP
Back Chamber Process	Ashing
Cool Down Chamber	Std
Transfer Robot	Std
Robot Blade	Missing
GEM &SESC Inferface	Std
Signal Tower	Std
Main PC	Std
DC Power Supply	Std



Side Chamber	N/A
Side Chamber Process	N/A
Cassette Stage	Std
AC Power Box	Std
EMO	Fush
Monitor	LCD
RF Generator	AE, CESAR1312
	AE, CESAR1312
AC Power Supply	Std

BACK Chamber Information

Chamber Type	Chamber Process	Chuck Type
ICP	Ashing	Std
Manometor	Chamber Pump	Cooling Water
Millipore	Present	N/A
RF Gen'r(Left)	RF Match (Left)	Gate Valve
AE, CESAR1312	Present	Std
RF Gen'r (Right)	RF Match (Right)	Throttle
AE, CESAR1312	Present	Std
Thermocuple	Heater	Pressure Swich
Std	Std	Std

Chamber Gas

	Gas Name	MFC Size	MFC Maker	MFC Model Number	Configuration
Gas 1	CF4	200 sccm	STEC	SEC-4400	
Gas 2	O2	10 slm	STEC	SEC-4400	
Gas 3					
Gas 4					
Gas 5					
Gas 6					
Gas 7					
Gas 8					
Gas 9					
Gas 10					
Gas 11					
Gas 12					

Missing Information

1. Robot Blade
2. Robot Extention Geneva
3. Robot Extention Gear
4. Robot Rotation Genva
5. Robot Rotation Gear
6. Robot Motor
7. Side Slit Door
8. Shattle Pressure Gauge
9. Shattle Chamber Slit Door
10. Shattle Motor

Parts Box Information

1. Signal tower X 1ea
2. Board X 1ea
3. Control box X 3ea
4. Power tap X 1ea
5. Hard Disk X 1ea
6. Throttle valve X 1ea
7. Chamber gate door X 1ea
8. Parnels X 1set
9. Pipes X 1set
10. Cables X 1set